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Substitute for Form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Application Number	09/938,412				
Filing Date	August 23, 2001				
First Named Inventor	Wan-Thai Hsu, et al.				
Group Art Unit					
Examiner Name					
Sheet	1	of	1	Attorney Docket Number	WOM 0210 PUSP

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
HR		HSU, WAN-THAI, ET AL., Geometric Stress Compensation For Enhanced Thermal Stability In Micromechanical Resonators, IEEE International Ultrasonics Symposium, October 5-8, 1998, pgs. 945-948.	

Examiner
Signature

Helen Kwik

Considered

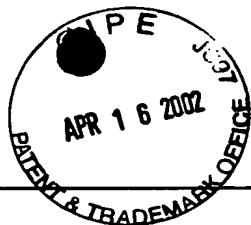
11/15/02

¹EXAMINER: Initial if reference is made and not considered. Include copy of the

²EP 609. Draw line through citation if not in conformance and

³Unique citation designation

Page Translation is attached.



Substitute for Form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	09/938,412
				Filing Date	August 23, 2001
				First Named Inventor	Wan-Thai Hsu, et al.
				Group Art Unit	2856
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	UOM 0211 PUSP
OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS					
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
HZ		NGUYEN, CLARK T.-C., Micromachining Technologies For Miniaturized Communication Devices, Proceedings of SPIE: Micromachining and Microfabrications, Santa Clara, CA, September 20-22, 1998, pages 24-38.			
HZ		WANG, KUN, ET AL., VHF Free-Free Beam High-Q Micromechanical Resonators, XP-000830790, January 17, 1999, pages 453-458.			
HZ		NGUYEN, CLARK T.-C., Frequency-Selective MEMS For Miniaturized Communication Devices, IEEE, 1998, pages 445-460			

Examiner Signature	Helen Kwik	Date Considered	11/15/02
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.